



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

Serial No. : 10/086,614

Art Unit : 1762

Filed : March 1, 2002

Examiner : W. Markham

For : Ion-Assisted Deposition Techniques For  
The Planarization Of Topological Defects

**APPLICATION FOR CHANGE IN CORRESPONDENCE ADDRESS and  
TELEPHONE NUMBER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please change the Correspondence Address for the above-identified  
application to:

**John P. Wooldridge  
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Please change the telephone number for the above-identified application to:

**808-875-0012**

If you have any questions, please contact the undersigned at 808-875-0012.

Respectfully submitted,

John P. Wooldridge  
Attorney for Applicant  
Registration No. 38,725

Dated: February 8, 2006